



500.42846X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: M. HASEGAWA, et al.

Serial No.: 10/628,275

Filed: JULY 29, 2003

Title: STAMPER, LITHOGRAPHIC METHOD OF USING THE STAMPER AND METHOD OF FORMING A STRUCTURE BY A LITHOGRAPHIC PATTERN

Group AU: 1763

Examiner: Roberts P. Culbert

Confirm. No.: 4715

AMENDMENT

Mail Stop: AMEND – FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

August 28, 2006

SIR:

In response to the Office Action mailed April 27, 2006, the period for response having been extended for one (1) month by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.